## 501934735 05/25/2012

# PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

# **CONVEYING PARTY DATA**

Name	Execution Date
Takeshi ANDOU	04/06/2012
Junichi FUJIMORI	04/11/2012
Hiroyuki YONEZAWA	04/12/2012
Yasumasa KAWABE	04/13/2012
Hideyuki NAKAMURA	04/16/2012

#### RECEIVING PARTY DATA

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## PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13416870

#### CORRESPONDENCE DATA

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Total Attachments: 1

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PATENT REEL: 028272 FRAME: 0434

# **ASSIGNMENT**

Whereas, I/we, Takeshi ANDOU of SHIZUOKA, JAPAN,
Junichi FUJIMORI of SHIZUOKA, JAPAN,
Hiroyuki YONEZAWA of SHIZUOKA, JAPAN,
Yasumasa KAWABE of SHIZUOKA, JAPAN,
Hideyuki NAKAMURA of SHIZUOKA, JAPAN

hereinafter called assignor(s), have inve	nted certain improvements in
MEMS STRUCTURE, METHOD FC	RODUCING THE PATTERN, METHOD FOR PRODUCING OR MANUFACTURING SEMICONDUCTOR DEVICE, AND R PRODUCING PLATED PATTERN
April 6.2012, April 11, 20 April 13, 2012 and April Whereas, FUJIFILM Corp	Patent of the United States of America therefor on ロン、April (2,20(2, ; and 1/6,20(2 Poration Pabu 2-chome, Minato-ku, TOKYO, JAPAN
and to any United States patents to be of Now therefore, for valuable consistency invention disclosed therein for the United 35 U.S.C. § 119, and I/we request the upon the invention set forth in the application without further consideration all the United States application when called I/We hereby authorize and repenselvania Avenue, N.W., Washington	sideration, receipt whereof is hereby acknowledged, nor(s), hereby sell, assign and transfer to the above named the entire right, title and interest in the application and the ed States of America, including the right to claim priority under Commissioner of Patents to issue any Letters Patent granted ration to the assignee, its successors and assigns; and I/we will papers deemed necessary by the assignee in connection with ed upon to do so by the assignee.  Request my/our attorneys SUGHRUE MION, PLLC of 2100 on, D.C. 20037-3213 to insert here in parentheses (Application attorn number 9854 , filed March 9, 2012 )
Date: 2012. 4.6	s/Takeshi Ando Takeshi ANDOU
Date: 2012.4.11	s/Junichi Fujimori  Junichi FUJIMORI
Date: 2012 . 4. 12	s/Hiroyuki Yonezawa Hiroyuki YONEZAWA
Date: 2012.4.13	s/ Kawabe

RECORDED: 05/28/20124. 16

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